



RECEIVED
JUN 18 2003
TC 1700

AMENDMENT UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE
GROUP 1725
PATENT APPLICATION

14/1
Sofia
6/19/03
NE

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q63075

Kazunobu FUJIKAWA, et al.

Appln. No.: 09/763,194

Group Art Unit: 1725

Confirmation No.: 3832

Examiner: Maria Alexandra ELVE

Filed: February 20, 2001

For: METHOD AND APPARATUS FOR SURFACE DISCHARGE PROCESSING, AND AN
ELECTRODE FOR SURFACE DISCHARGE PROCESSING

AMENDMENT UNDER 37 C.F.R. § 1.116

MAIL STOP AF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated February 13, 2003, along with a Petition for Extension of Time and appropriate fee, please amend the above-identified application as follows on the accompanying pages and as allowed by the new format specified in the Pre-OG Notice of January 31, 2003, entitled, *Amendments in a Revised Format Now Permitted*, wherein the requirements of 37 C.F.R. § 1.121 (a - d) have been waived.